

Course Schedule, group M16-602**MONDAY**

08:30 — 10:05	■	LEC	Opt	Military Training (2017-02-06 — 2017-05-15) ♣ dep.20
10:15 — 16:05	■	SEM	Opt	Military Training (2017-02-06 — 2017-05-15) ♣ dep.20

TUESDAY

11:55 — 15:15	■	LAB		Experimental Methods of Nuclear Physics 4 зан. ♣ Sharapov A.S., Ibragimov R.F., Tyurin E.M. ♣ D-109
	■	LAB		Registration of Fast Rate Processes 4 зан. ♣ Sharapov A.S., Tyurin E.M., Ibragimov R.F. ♣ D-109
16:15 — 17:50	■	SEM	Elect	Computer Design of Circuit Diagrams ♣ Mescheryakov V.V. ♣ K-205
	■	SEM	Elect	Application of Automated Design Systems at a Facility (CAD System Creo Parametric) ♣ Kozyrev D.B. ♣ V-106
	■	LEC	Elect	Computer Design of Circuit Diagrams ♣ Mescheryakov V.V. ♣ K-202
	■	LEC	Elect	Application of Automated Design Systems at a Facility (CAD System Creo Parametric) ♣ Kozyrev D.B. ♣ V-106
17:55 — 19:30	■	LEC		Radiation Resistance of Nuclear-physical Devices and Components ♣ Butin V.I. ♣ B-212st
	■	SEM		Radiation Resistance of Nuclear-physical Devices and Components ♣ Butin V.I. ♣ B-212st

WEDNESDAY

10:15 — 11:00	■	SEM	Elect	Analog Integrated Devices for Measuring Systems ♣ Maslennikov V.V. ♣ K-1006
11:05 — 11:50	■	SEM	Elect	Analog Integrated Devices for Measuring Systems ♣ Maslennikov V.V. ♣ K-1006
12:45 — 14:20	■	SEM		Experimental Methods of Nuclear Physics ♣ Kadilin V.V. ♣ D-101
14:30 — 16:05	■	SEM		Practical Training (Research Work) ♣ Yurkov D.I. ♣ dep.24
	■	SEM		Computer Workshop: Software Packages for Simulation of Ionizing Radiation and Matter Interaction ♣ Idalov V., Ryabeva E.V. ♣ K-417
16:15 — 17:50	■	SEM	Elect	Nuclear Physics Methods. Neutron Methods of Elemental Analysis (2017-02-08 — 2017-04-19) ♣ Karetnikov M.D., Batyaev V.F. ♣ D-101

FRIDAY

10:15 — 11:50	■	LEC		Principles of Information Security (2017-02-10 — 2017-04-28) ♣ Malyuk A.A. ♣ 407
12:45 — 14:20	■	LEC		Experimental Methods of Nuclear Physics ♣ Kadilin V.V., Ergashev D.E. ♣ B-208
14:30 — 16:05	■	LAB	Elect	Nuclear Physics Methods. Neutron Methods of Elemental Analysis ♣ Zverev V.I., Karetnikov M.D., Batyaev V.F. ♣ D-116
14:30 — 17:50	■	LAB	Elect	Analog Integrated Devices for Measuring Systems 4 зан. (2017-02-10 — 2017-03-24) ♣ Maslennikov V.V. ♣ K-1009
15:20 — 17:00	■	SEM		Practical Training (Research Work) ♣ Yurkov D.I. ♣ VNIIA (m. Tsaritsyno)
17:55 — 19:30	■	LEC		Registration of Fast Rate Processes ♣ Ergashev D.E. ♣ D-101
	■	SEM		Registration of Fast Rate Processes ♣ Ergashev D.E. ♣ D-101

SATURDAY

08:30 — 10:05	■	SEM		Foreign Language ♣ Hachaturova E.G. ♣ A-306
10:15 — 11:50	■	SEM	Elect	Numerical Modeling GEANT ♣ Idalov V.A., Dedenko G.L. ♣ V-116
	■	SEM	Elect	Measuring of Electromagnetic Process Parameters ♣ Reshetov V.N. ♣ K-805
	■	SEM	Elect	Measuring of Electromagnetic Process Parameters ♣ Reshetov V.N. ♣ K-805